

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Myoung-Ho Jung

Examiner: Gregory E. Webb

Serial No.: 10/748,903

Group Art Unit: 1751

Filed: December 30, 2003

For: **CLEANING SOLUTION USED IN PROCESS OF FABRICATING  
SEMICONDUCTOR DEVICE**

Mail Stop: RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated December 12, 2006 and the Advisory  
Action dated March 2, 2007, please amend the above-referenced patent application as set  
forth herein. Also, accompanying this amendment is a Request for Continued  
Examination (RCE).

-----